



IN THE UNITED STATES PATENT & TRADEMARK OFFICE

Application Number : 10/731,487 Confirmation No. 5410
Applicant : Sung Bo HWANG
Filed : 12/10/2003
Tech Cntr/AU : 2822
Examiner : Thomas, Toniae M
Entitled : METHOD OF FORMING INSULATING FILM IN SEMICONDUCTOR
DEVICE

Attorney Reference : 123034-05004817
Customer Number : 43569

MAIL STOP AMENDMENT

Commissioner for Patents
P.O. Box 1450
Alexandria, Virginia 22313-1450

AMENDMENT/RESPONSE TRANSMITTAL

Transmitted herewith is an amendment/response for this application.

EXTENSION OF TIME

A petition for extension of time under 37 C.F.R. 1.136 is not believed necessary.

CLAIM FEES

The claim fees have been calculated as follows:

	CLAIMS REMAINING AFTER AMENDMENT	HIGHEST NO. PREVIOUSLY PAID FOR	PRESENT EXTRA	RATE	ADDITIONAL FEE
Total	10	-	20	= 0 x \$ 50.00	= \$ 0.00
Independent	2	-	3	= 0 x \$ 200.00	= \$ 0.00
FIRST PRESENTATION OF MULTIPLE DEP. CLAIM+ \$ 360.00					= \$ 0.00
TOTAL ADDITIONAL CLAIM FEE DUE					\$ 0.00

FEE PAYMENT

Authorization is given herein to charge the any deficiencies in the fees not specifically authorized herein, or to further credit any overpayments, to Deposit Account No. 503-121 in order to maintain the pendency of this application.

Intellectual Property Department
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Date: February 18, 2005